



Docket No.: M4065.0528/P528-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Cem Basceri et al.

Allowed: October 28, 2005

Application No.: 10/659,435

Confirmation No.: 4094

Filed: September 11, 2003

Art Unit: 2814

For: METHOD OF FORMING MIS
CAPACITOR

Examiner: N. W. Ha

**COMMENTS ON STATEMENT OF REASONS
FOR ALLOWANCE UNDER 37 C.F.R. § 1.104(E)**

MS Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

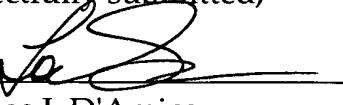
Applicants have received the Examiner's Statement of Reasons for Allowance with the October 28, 2005 Notice of Allowance and Allowability regarding the above-identified application. Applicants agree that the claims are patentable. However, entry of the Examiner's Statement into the record should not be construed as any agreement with or acquiescence in the reasoning stated by the Examiner. Each of the claims stands on its own merits and is patentable because of the combination of features it recites and not because of the presence or absence of any one particular element.

The Examiner's Statement was not prepared by Applicants and only contains the Examiner's possible positions in one or more reasons for allowability. Thus, any

interpretation with respect to the Examiner's Statement of Reasons for Allowance should not be imputed to the Applicants.

Dated: January 25, 2006

Respectfully submitted,

By 
Thomas J. D'Amico

Registration No.: 28,371

Gabriela I. Coman

Registration No.: 50,515

DICKSTEIN SHAPIRO MORIN &
OSHINSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 785-9700

Attorneys for Applicants